

EFW



CERTIFICATE OF MAILING 37 C.F.R. § 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
July 7, 2004 Date	<i>Mary Paul</i> Signature

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KARSTEN WIECZOREK
FALK GRAETSCH
LUTZ HERRMANN

Group Art Unit: 1765

Examiner: Unknown

Serial No.: 10/693,024

Atty. Dkt. No.: 2000.108600/DE0362

Filed: October 24, 2003

Customer No.: 23720

For: TECHNIQUE FOR FORMING AN
OXIDE/NITRIDE LAYER STACK BY
COMPENSATING NITROGEN NON-
UNIFORMITIES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. A copy of the listed journal article required by 37 C.F.R. § 1.98(a)(2) is enclosed for the convenience of the Examiner. Because the filing date of the present application is after June 30, 2003, copies of the listed U.S. patents are not included.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

In accordance with 37 C.F.R. § 1.97(e)(1), Applicants hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the present statement, as evidenced by the date of the enclosed PCT Search Report.

Applicants respectfully request that the listed documents be made of record in the present case.

Respectfully submitted,

WILLIAMS, MORGAN & AMERSON
CUSTOMER NUMBER 23720



Date: July 7, 2004

J. Mike Amerson
Reg. No. 35,426
10333 Richmond, Suite 1100
Houston, Texas 77042
(713) 934-4055
(713) 934-7011 (facsimile)

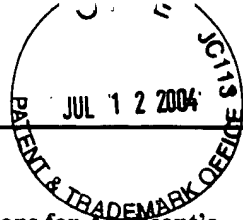
ATTORNEY FOR APPLICANTS

Form PTO-1449 (modified)

List of Patents and Publications for Applicant's

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)


 Atty. Docket No.
2000.108600/DE0362

 Serial No.
10/693,024

 Applicant
Karsten Wieczorek, Falk Graetsch and Lutz Herrmann

 Filing Date:
October 24, 2003

 Group:
1765

 U.S. Patent Documents
See Page 1

 Foreign Patent Documents
See Page 1

 Other Art
See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	6,194,288 B1	2/27/01	Fahn <i>et al.</i>	438	440	
	A2	2002/0130377 A1	9/19/02	Khare <i>et al.</i>	257	410	
	A3						
	A4						
	A5						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						
	B2						
	B3						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	Josquin and Tamminga, "The Oxidation Inhibition in Nitrogen-Implanted Silicon," <i>J. Electrochem. Soc.</i> , 129:1803-11, 1982.
	C2	
	C3	

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.